## DIFUNCTIONAL CYCLOPOLYMERIZABLE MONOMERS FOR REDUCED SHRINKAGE OF PHOTOPOLYMERIZABLE NETWORKS

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Cyclopolymerizable monomers (CPM) with non-conjugated dienes as polymerizable unit perform radical polymerization via an intra-intermolecular polymerization mechanism (Figure 1). This leads to the formation of cyclic units in the polymer backbone, influencing particularly the shrinkage behavior during photopolymerization. [1] The cyclization tendency can be traced back to the poor homopolymerization behavior of the

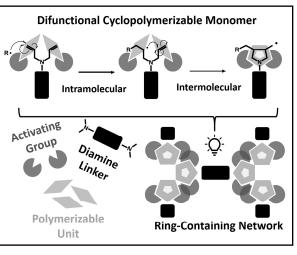


Figure 1: Cyclopolymerization

corresponding monoene monomers. State-of-the-art coating applications use allyl-based moieties as CPMs and therefore they were used as basic motif in this study. Novel diamine-linked difunctional 1,6-diene CPMs based on photopolymerizable moieties with varying double bond activation (allyl-, methacryloyl-, and ester-activated allyl-moieties) have been synthesized and characterized to demonstrate their influence on reactivity, shrinkage behavior, and mechanical properties by means of photo-DSC, photorheology, DMTA, and tensile testing upon radical photopolymerization. Comparison between activated CPMs and monoene compounds highlight improved reactivities (up to 60%), reduced shrinkage behavior (up to 40%), and enhanced mechanical properties of these novel difunctional compounds caused by double bond activation and ring formation in the polymer backbone upon curing.

<sup>[1]</sup> Peer, G., et al., *Photopolymerization of Cyclopolymerizable Monomers and Their Application in Hot Lithography*. Macromolecules, 2018. **51**(22): p. 9344-9353.